

AMENDMENTS TO THE SPECIFICATION

Please amend the specification as detailed below. This amendment does not add new matter, but merely corrects an extraneous term included through an inadvertent typographical error. Please amend the paragraph at page 8, lines 14-25 as follows:

Reader 34 includes upper shield 48, lower shield 50, and MR read sensor 52. Reader 34 is located upon substrate 38, which is typically formed of an electrically conductive material AlTiC, TiC, Si, SiC, Al_2O_3 , or other composite materials formed of combinations of these materials. Insulator 56 separates lower shield 50 of reader 34 from substrate 38. Upper shield 48 is parallel to lower shield 50. MR read sensor 52 is disposed between upper and lower shields 48 and 50. MR read sensor 52 and upper and lower shields 48 and 50 are generally parallel to each other, and also abut ABS 58. Insulator 56 extends between upper and lower shields 48 and 50, and is generally formed of an oxide, such as Al_2O_3 , AlN, SiO_2 , Si_3N_4 , or $\text{SiO}_{0.2}\text{N}_{0.1.5}$. While insulator 56 is shown in FIG. 1 as a contiguous element, insulator 56 may be fabricated by depositing a number of layers of insulating material in transducing head 32.